Atty. Docket No. 033082R167

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants

Taro IKEDA

Confirmation No. 8788

erial No.

10/635,651

Art Unit: 1763

iled

August 7, 2003

Examiner: Luz L. Alejandro

Mulero

For:

PLASMA PROCESSING SYSTEM AND PLASMA PROCESSING

METHOD

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action of July 27, 2005 in the form of a Restriction Requirement, Applicant's elect claim Group II noted in the Office Action as being represented by Claims 5-11. Applicant's reserve the right to file a divisional application for the non-elected subject matter and seek rejoinder upon a dependency change.

Respectfully submitted,

SMITH, GAMBRELL & RUSSELL, LLP

By:

Dennis C. Rodgers Registration No. 32,936

1850 M Street, NW - Suite 800

Washington, DC 20036 Telephone: 202/263-4300

Facsimile: 202/263-4329

Date: August 24, 2005